

FORM PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 100564-00049	SERIAL NO. New Application
LIST OF REFERENCES CITED BY APPLICANT <i>(Use several sheets if necessary)</i>				APPLICANT STÄHLER et al	
				FILING DATE February 28, 2001	GROUP

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB-CLASS	FILING DATE
PP	AA	5,318,679	6/7/94	Nishioka			
PP	AB	5,424,186	6/13/95	Fodor et al			

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES NO
PP	AC	98 08085	2/26/88	WO			
	AD	99 41007	8/19/99	WO			
	AE	99 42813	8/26/99	WO			
	AF	99 60156	11/25/99	WO			
	AG	99 63385	12/9/99	WO			
✓	AH	98 13683	4/2/98	WO			

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

PP	AI	Davidson, "A microlens direct-write concept for lithography", INSTITUTE OF ELECTRICAL ENGINEERS, vol. 3048, pgs. 346-355.
	AJ	Bertsch et al., "Study of the spatial resolution of a new 3D microfabrication process...." CHEMICAL ABSTRACTS, vol. 127, no. 15, 13 October 1997
	AK	Sangeet et al., "Maskless fabrication of light-directed oligonucleotide microarrays using a digital micromirror array", NATURE BIOTECHNOLOGY, vol. 17, October 1999, pgs. 974-978.
	AL	Retrieved from the Internet: "Digital Optical Chemistry", retrieved on 12/20/99, URL: <a href="http://pompous.swmed.edu/exptbio/doc">http://pompous.swmed.edu/exptbio/doc</a>
	AM	Johnson et al., "Micromirror arrays perform photolithography step", EETTIMES. COM Online, 20 December 1999.
✓	AN	Bertsch et al., "Study of the spatial resolution of a new 3D microfabrication process....", CHEMICAL ABSTRACTS, vol. 127, no. 15, 13 October 1997

EXAMINER P. Ponnalun	DATE CONSIDERED 1/18/05
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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